

<b>Notice of References Cited</b>		Application/Control No. 09/945,555	Applicant(s)/Patent Under Reexamination GILGEN ET AL.	
		Examiner Evan Pert	Art Unit 2829	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,162,248	11-1992	Dennison et al.	438/396
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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	N					
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	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	I. Yamamoto, "Low-temperature Metal/ON/HSG-Cylinder Capacitor Process for High Density Embedded DRAMs," 1999 Symposium on VLSI Technology Digest of Technical Papers, , pages 157-158.
	V	
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	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.